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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100176)

First Inventor: Roland K. Sevilla
Serial No.: 10/601,601
Filing Date: 06/23/2003
Title: POLISHING PAD FOR
ELECTROCHEMICAL-
MECHANICAL POLISHING
Examiner: Maurina T. Rachuba
Art Unit: 3723

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P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

This is a reply to the Office Action mailed 02/16/2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 5 of this paper.

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